

PRELIMINARY PROGRAM



Sponsored by



The Executive Committee reserves the right to amend the program if necessary

Sunday, June 3

6:00 pm - Registration and Welcome Reception
9:00 pm

Monday, June 4

7:00 am Breakfast

7:45 am **Welcome**

Tina Lamers, *Uber ATG, USA*

Mina Rais-Zadeh, *University of Michigan, USA*

Plenary Presentation I

Session Chair: M. Rais-Zadeh, *University of Michigan, USA*

8:15 am **ENABLING THE NEXT GENERATION OF MEMS TECHNOLOGY**

William Chappell¹, R.H. Olsson III¹, and R.G. Polcawich^{1,2}

¹*DARPA, USA* and ²*US Army Research Laboratory, USA*

Session 1 - Physics of Microfluidics

Session Chair: C. Buie, *Massachusetts Institute of Technology, USA*

9:05 am **PROBING THE FUNDAMENTAL EVAPORATION LIMIT
WITH A NANOPOROUS MEMBRANE DEVICE**

Z. Lu¹, K.L. Wilke¹, I. Kinefuchi², and E.N. Wang¹

¹*Massachusetts Institute of Technology, USA* and

²*University of Tokyo, JAPAN*

9:25 am **A MICROFLUIDIC DEVICE FOR MECHANICAL PROFILING
OF HYDROGEL MICROPARTICLES**

Y. Niu and Y. Zhao

Ohio State University, USA

9:45 am **DROPLET MANIPULATION ON A SURFACE WITH
ANISOTROPIC WETTABILITY USING IN-PLANE
SYMMETRIC CYCLIC VIBRATION**

L. Qi, C. Ruck, and Y. Zhao

Ohio State University, USA

10:05 am **Break and Table Top Exhibits**

Session 2 - Optical Microsystems

Session Chair: J. Gorman, *National Institute of Standards & Technology (NIST), USA*

10:30 am TUNABLE COLOR REFLECTOR WITH ZERO STATIC POWER

M. Jafari¹, L.J. Guo¹, and M. Rais-Zadeh^{1,2}

¹*University of Michigan, USA and*

²*NASA Jet Propulsion Laboratory (JPL), USA*

10:50 am A RECONFIGURABLE OPTOFLUIDIC DEVICE FOR ADAPTIVE IMAGING AND POSITION ESTIMATION WITH A WIDE FIELD OF VIEW

H. Huang and Y. Zhao

Ohio State University, USA

11:10 am BIOINSPIRED MULTIFUNCTIONAL NANOSTRUCTURES FOR MICRO-OPTICAL IMPLANTS

V. Narasimhan¹, R.H. Siddique¹, J.O. Lee¹, S. Kumar¹,

B. Ndjamen¹, J. Du², N. Hong¹, D. Sretavan², and H. Choo¹

¹*California Institute of Technology, USA and*

²*University of California, San Francisco, USA*

11:30 am Preview of Poster Session 1 Presentations

Session Chairs: E. Briot, *Qorvo, USA* and

J. Chan, *ECS Federal, LLC, USA*

12:00 pm Networking Lunch

Poster Session 1

Session Chair: D. Weinstein, *Purdue University, USA*

1:30 pm Contributed and Late News

See page 11 for listing of poster presentations

4:00 pm End of Day

Tuesday, June 5

7:00 am **Breakfast**

7:10 am - **GUIDANCE TO ACHIEVING SUCCESS WITH NSF**

7:45 am **PROPOSALS: A PROGRAM DIRECTOR'S VIEW**

Shubhra Gangopadhyay

National Science Foundation (NSF), USA

8:10 am **Announcements**

Plenary Presentation II

Session Chair: A. Herr, *University of California, Berkeley, USA*

8:15 am **TOWARDS INDUSTRIALISATION OF MICROFLUIDIC SAMPLE-TO-ANSWER SOLUTIONS ENABLING POINT-OF-USE TESTING OF BIOSAMPLES: A DESIGN-FOR-MANUFACTURE LED PLATFORM APPROACH**

Jens Ducreé

Dublin City University, Ireland

Session 3 - Wearable Devices

Session Chair: Y.-K. Yoon, *University of Florida, USA*

9:05 am **PRECISION HIGH-BANDWIDTH OUT-OF-PLANE ACCELEROMETER AS CONTACT MICROPHONE FOR BODY-WORN AUSCULTATION DEVICES**

P. Gupta, Y. Jeong, J. Choi, M. Faingold, A. Daruwalla, and F. Ayazi
Georgia Institute of Technology, USA

9:25 am **MICROFABRICATED ELECTRODYNAMIC WIRELESS POWER RECEIVER FOR BIO-IMPLANTS AND WEARABLES**

N. Garraud, D. Alabi, J.D. Varela, D.P. Arnold, and A. Garraud
University of Florida, USA

9:45 am **A WIRELESSLY CONTROLLED FULLY IMPLANTABLE MICROSYSTEM FOR NANO-LITER RESOLUTION INNER EAR DRUG DELIVERY**

F. Forouzandeh¹, A. Alfadhel¹, X. Zhu², J.P. Walton²,
D.R. Cormier¹, R.D. Frisina², and D.A. Borkholder¹

¹*Rochester Institute of Technology, USA and*

²*University of South Florida, USA*

10:05 am **Break and Table Top Exhibits**

Session 4 - Microsystems for Biological Applications

Session Chair: M. Ziaei, *iSono Health, USA*

**10:30 am MULTISCALE LIQUID METAL THIN-FILM PATTERNING BASED
ON SOFT LITHOGRAPHY FOR SKIN-MOUNTABLE, SOFT
AND 3D-INTEGRATED BIOLOGICAL MICROSYSTEMS**

M. Kim, C. Kim, H. Alrowais, P. Getz, and O. Brand
Georgia Institute of Technology, USA

**10:50 am ROBUST AND SCALABLE TISSUE-ENGINEERED
ELECTRONIC NERVE INTERFACES (TEENI)**

C.A. Kuliasha, B.S. Spearman, E.W. Atkinson, P. Rustogi,
A.S. Furniturewalla, E.A. Nunamaker, K.J. Otto, C.E. Schmidt,
and J.W. Judy
University of Florida, USA

11:10 am One Man's Purpose – A Radio Play

12:15 pm - Networking Lunch

1:45 pm

7:00 pm - Tuesday Banquet

10:00 pm

Wednesday, June 6

7:15 am Breakfast

7:15 am Women in MEMS

8:10 am Announcements

Plenary Presentation III

Session Chair: F. Ayazi, *Georgia Institute of Technology, USA*

8:15 am **WIRELESS INTEGRATED MICRO SYSTEMS (WIMS):
PAST, PRESENT, FUTURE**
Khalil Najafi
University of Michigan, USA

Session 5 - Levitated, Flying & Running Microrobots

Session Chair: S. Bergbreiter, *University of Maryland, USA*

9:05 am **A SIX-LEGGED MEMS SILICON ROBOT USING
MULTICHIP ASSEMBLY**
D.S. Contreras and K.S.J. Pister
University of California, Berkeley, USA

9:25 am **A 3D-PRINTED 1 MG LEGGED MICROROBOT RUNNING
AT 15 BODY LENGTHS PER SECOND**
R. St. Pierre¹, W. Gosrich², and S. Bergbreiter¹
¹*University of Maryland, USA and*
²*State University of New York, Buffalo, USA*

9:45 am **BATCH-FABRICATION OF DIAMAGNETICALLY
LEVITATED MICROROBOTS**
C. Velez¹, R.E. Pelrine², A. Wong-Foy², and D.P. Arnold¹
¹*University of Florida, USA and* ²*SRI International, USA*

10:05 am **TAKEOFF OF A FLYING MICROROBOT WITH COTS SENSOR
PAYLOAD USING ELECTROHYDRODYNAMIC THRUST
PRODUCED BY SUB-MILLIMETER CORONA DISCHARGE**
D.S. Drew and K.S.J. Pister
University of California, Berkeley, USA

10:25 am Break and Table Top Exhibits

Session 6 - Micro-Resonators & Resonator-Based Frequency Combs

Session Chair: A. Duwel, *Charles Stark Draper Laboratory, Inc., USA*

- 10:50 am A FERROELECTRIC CAPACITOR (FECAP) BASED UNRELEASED RESONATOR**
Y. He¹, B. Bahr², and D. Weinstein¹
¹Purdue University, USA and ²Texas Instruments, USA
- 11:10 am PIEZOELECTRIC SINGLE CRYSTAL 6H SILICON CARBIDE MICROELECTROMECHANICAL RESONATORS**
R. Perahia, L.D. Sorenson, J.L. Bregman, L.X. Huang, M.S. White, K.S. Holabird, and D.T. Chang
HRL Laboratories, LLC, USA
- 11:30 am FREQUENCY COMB GENERATION IN A NONLINEAR RESONATOR THROUGH MODE COUPLING USING A SINGLE TONE DRIVING SIGNAL**
D.A. Czaplewski¹, S.W. Shaw², O. Shoshani³, M.I. Dykman⁴, and D. Lopez¹
¹Argonne National Laboratory, USA, ²Florida Institute of Technology, USA, ³Ben-Gurion University of the Negev, ISRAEL, and ⁴Michigan State University, USA
- 11:50 am ULTRA-HIGH Q MONOCRYSTALLINE SILICON CARBIDE DISK RESONATORS ANCHORED UPON A PHONONIC CRYSTAL**
J. Yang, B. Hamelin, S.-D. Ko, and F. Ayazi
Georgia Institute of Technology, USA
- 12:10 pm - Poster Preview of Poster Session 2 Presentations**
Session Chairs: A. Lal, *Cornell University, USA* and M.A. Maher, *SoftMEMS, USA*
- 12:40 pm - Networking Lunch**

Poster Session 2

Session Chair: M. Motiee, *Analog Devices, USA*

- 2:10 pm - Contributed and Late News**
4:40 pm See page 17 for listing of poster presentations

Poster Session 3

Session Chair: Q. Zou, *Avago Technologies, USA*

- 6:30 pm - Commercial and Open Posters**
See page 23 for listing of poster presentations

- 8:00 pm - Awards Ceremony**

- 8:15 pm RUMP Session**
10:00 pm

Thursday, June 7

7:30 am Breakfast

8:10 am Announcements

Plenary Presentation IV

Session Chair: T. Lamers, *Uber ATG, USA*

8:15 am TOWARDS INTEGRATED OPTICAL GYROS USING BRILLOUIN LASERS

Kerry Vahala, Y.H. Lai, M.G. Suh, J. Li, and K.Y. Yang
California Institute of Technology, USA

Session 7 - Late News Frequency-References, -Combs, and -Shifting Sensors

Session Chair: R. Perahia, *HRL Laboratories, USA*

9:05 am A NEW LOW POWER MEMS DUAL MODE CLOCK WITH PPB STABILITY OVER TEMPERATURE

L. Comenencia Ortiz¹, H.-K. Kwon¹, J. Rodriguez¹, D.B. Heinz¹, Y. Chen², G.D. Vukasin¹, D.D. Shin¹, and T.W. Kenny¹
¹*Stanford University, USA* and ²*Apple, Inc., USA*

9:25 am TOWARDS REAL-TIME MIDDLE ULTRAVIOLET (MUV) LIGHT DETECTION BY BETA GALLIUM OXIDE (β -Ga₂O₃) NEMS OSCILLATOR

X.-Q. Zheng¹, J. Lee¹, S. Rafique^{1,2}, M. Rezaul Karim², L. Han^{1,2}, H. Zhao², C.A. Zorman¹, and P.X.-L. Feng¹
¹*Case Western Reserve University, USA* and ²*Ohio State University, USA*

9:45 am SELF-SUSTAINED DUAL-MODE MECHANICAL FREQUENCY COMB SENSORS

M. Park and A. Ansari
Georgia Institute of Technology, USA

10:05 am Break and Table Top Exhibits

Session 8 - Late News Advanced Processes for Bio Applications

Session Chair: A. Lal, *Cornell University, USA*

- 10:30 am** **ENTERIC & 3D-PRINTED HYBRID PACKAGE FOR SAMPLING IN DIGESTIVE REGIONS**
G.E. Banis, L.A. Beardslee, J.M. Stine, and R. Ghodssi
University of Maryland, USA
- 10:50 am** **ROBUST “RIBBED” NANOPOROUS MEMBRANES FOR IMPLANTABLE BIO-ARTIFICIAL KIDNEYS**
B.W. Chui, P. Taheri-Tehrani, N. Wright, J. Ly, and S. Roy
University of California, San Francisco, USA
- 11:10 am** **AN ULTRASONICALLY POWERED IMPLANTABLE MICRO ELECTROLYTIC ABLATION (IMEA) FOR TUMOR NECROSIS**
A.K. Majumdar, S. Islam, and A. Kim
Temple University, USA
- 11:30 am - Networking Lunch**
1:00 pm
- 1:00 pm** **Workshop Adjourns**

Poster Session 1

Contributed and Late News

Monday, June 4

1:30 pm – 4:00 pm

Acoustic Transducers and Delay Lines

MP-01 A RADIO FREQUENCY NON-RECIPROCAL NETWORK BASED ON SWITCHED LOW-LOSS ACOUSTIC DELAY LINES

R. Lu, T. Manzaneeque, Y. Yang, A. Gao, L. Gao, and S. Gong
University of Illinois, Urbana-Champaign, USA

MP-02 PMUT-BASED HIGH DATA RATE ULTRASONIC WIRELESS COMMUNICATION LINK FOR INTRA-BODY NETWORKS

B. Herrera, E. Demirors, G. Chen, R. Guida, F. Pop, N. Dave, C. Cassella, T. Melodia, and M. Rinaldi
Northeastern University, USA

Bio-Inspiration and Biomedical Devices and Systems

MP-03 ELECTRIC-FIELD INDUCED INCREASE IN PARACELLULAR VASCULAR PERMEABILITY

K.K. Rangharajan, P. Mohanasundaram, J. Morris, E. Akbari, G.B. Spsychalski, J.W. Song, and S. Prakash
Ohio State University, USA

MP-04 MULTIMODAL INTELLIGENT TRANSWELL SYSTEM

P. Ramiah Rajasekaran, A. Chapin, D.N. Quan, S.H. Jang, L. Hu, J. Herberholz, W.E. Bentley, and R. Ghodssi
University of Maryland, USA

Characterization, Fabrication and Materials

MP-05 2D AND 3D DOPING OF SILICON MEMS STRUCTURES USING PHOSPHORUS-DOPED POLYSILICON AS A DOPANT SOURCE

P.J. Newby¹, K. Zandi¹, K. Côté¹, J.-P. Richard¹, K.-A. Belarbi²
¹*MiQro Innovation Collaborative Centre (C2MI), CANADA, and*
²*Teledyne DALSA Semiconductor Inc., CANADA*

MP-06 FABRICATION AND SUB-ASSEMBLY OF ELECTROSTATICALLY ACTUATED SILICON NITRIDE MICROSHUTTER ARRAYS

L.H. Oh¹, M.J. Li², K. Kim³, D. Kelly², A. Kutyrev⁴, S.H. Moseley², N.P. Costen¹, and G. Manos²
¹*SGT Inc., USA,* ²*NASA, USA,* ³*ASRC Federal Corp., USA, and*
⁴*University of Maryland, USA*

- MP-07 FABRICATION AND CHARACTERIZATION OF 3D PRINTED, 3D MICROELECTRODE ARRAYS WITH SPIN COATED INSULATION AND FUNCTIONAL ELECTROSPUN 3D SCAFFOLDS FOR “DISEASE IN A DISH” AND “ORGAN ON A CHIP” MODELS**
N. Azim¹, T. Ausaf¹, A. Kundu¹, L. Zhai¹, and S. Rajaraman^{1,2}
¹University of Central Florida, USA and
²Bridging the Innovation Development Gap (BRIDG), USA
- MP-08 FABRICATION OF SUB-MICRON METAL WIRES FOR HIGH-FREQUENCY LITZ WIRE**
K.J. Russell¹, A. Aydin², D.J.D. Carter¹, E. Kim¹, P.H. Lewis¹, L. Sun², X. Gong², C. Chang², R. Gordon², and A. Duwel¹
¹Charles Stark Draper Laboratory, Inc., USA and
²Harvard University, USA
- MP-09 FIRST FATIGUE MEASUREMENTS ON THICK EPI-POLYSILICON MEMS IN ULTRA-CLEAN ENVIRONMENT**
A.L. Alter¹, I.B. Flader¹, Y. Chen², L. Comenencia Ortiz¹, D.D. Shin¹, D.B. Heinz¹, and T.W. Kenny¹
¹Stanford University, USA and ²Apple Inc., USA
- MP-10 INCREASING THE THICKNESS AND DEPOSITION RATE OF HIGH-PERFORMANCE ELECTROPLATED CoPt PERMANENT MAGNETS**
Y. Wang, J. Ewing, and D.P. Arnold
University of Florida, USA
- MP-11 MASKLESS 3D MICROFABRICATION OF DRUG-LADEN CAPSULATED MICROSTRUCTURES**
L. Qi, S. Yuan, R.X. Xu, and Y. Zhao
Ohio State University, USA
- MP-12 PRINTING BIOLOGICAL LIQUID ON HYDROPHOBIC 3D ELECTRODES**
S. Chu, M.J. Lerman, J.N. Culver, J.P. Fisher, and R. Ghodssi
University of Maryland, USA

Chemical, Biomedical, and Gas Sensors

- MP-13 A BIODEGRADABLE SENSOR HOUSED IN 3D PRINTED POROUS TUBE FOR IN-SITU SOIL NITRATE DETECTION**
H. Jiang, W. Yu, R. Rahimi, and B. Ziaie
Purdue University, USA
- MP-14 A SUB-PPB-LEVEL INTEGRATED ELECTROCHEMICAL HEAVY METAL ION MICROSENSOR**
H. Jiang¹, C. Yang², K. Yang², and L. Dong²
¹Iowa State University, USA and ²Analog Devices Inc., USA

MP-15 FLEXIBLE IMPEDANCE SENSOR FOR WIRELESS MONITORING OF CATHETER BIOFILMS
R.C. Huiszoon, J.M. Stine, L.A. Beardslee,
P. Ramiah Rajasekaran, W.E. Bentley, and R. Ghodssi
University of Maryland, USA

Micro Robots

MP-16 FIRST LEAPS OF AN ELECTROSTATIC INCHWORM MOTOR-DRIVEN JUMPING MICROROBOT
J. Greenspun and K.S.J. Pister
University of California, Berkeley, USA

MP-17 SOFT ROBOTICS: FLUID-DRIVEN SELF-FOLDING PAPERS
H.-H. Chun, M. Mohammadifar, and S. Choi
State University of New York, Binghamton, USA

Microfluidics

MP-18 THE μ HAMMER: INVESTIGATING CELLULAR RESPONSE TO IMPACT WITH A HIGH THROUGHPUT MICROFLUIDIC MEMS DEVICE
L.H.C. Patterson¹, J.L. Walker¹, E. Rodriguez-Mesa², K. Shields²,
J.S. Foster², M.T. Valentine¹, A.M. Doyle¹, and K.L. Foster^{1,2}
¹*University of California, Santa Barbara, USA and*
²*Owl Biomedical, USA*

MP-19 TRANSIENT BIOBATTERIES: MICROFLUIDIC CONTROL FOR PROGRAMMABLE DISSOLUTION
M. Mohammadifar and S. Choi
State University of New York, Binghamton, USA

MP-20 VOLTAGE GATED NANOFLUIDIC CHIP FOR PROTEIN CAPTURE, AMPLIFICATION, AND RELEASE
K.K. Rangharajan and S. Prakash
Ohio State University, USA

Modeling

MP-21 A FLEXIBLE, MICROFABRICATED IMPEDIMETRIC FLUID TEMPERATURE SENSOR
A. Baldwin, T. Hudson, E. Yoon, and E. Meng
University of Southern California, USA

MP-22 EFFECT OF DIELECTRIC LOSS ON THE QUALITY FACTORS OF PIEZOELECTRICALLY DRIVEN LENGTH EXTENSIONAL MODE RESONATORS
A. Qamar¹, S. Sherrit², X.-Q. Zhang³, J. Lee³, P.X.-L. Feng³,
and M. Rais-Zadeh^{1,2}
¹University of Michigan, USA, ²California Institute of Technology, USA, and ³Case Western Reserve University, USA

Physical and Optical Sensors and Actuators

MP-23 BROADBAND LONG-WAVELENGTH INFRARED MICROMECHANICAL PHOTOSWITCH FOR ZERO-POWER HUMAN DETECTION
S. Kang, S.D. Caliskan, Z. Qian, V. Rajaram, N.E. McGruer,
and M. Rinaldi
Northeastern University, USA

MP-24 FBAR-BASED SENSOR FOR WIRELESS RFID AUTHENTICATION OF INTEGRATED CIRCUITS
A.A. Shkel, M. Barekatin, and E.S. Kim
University of Southern California, USA

MP-25 THE EFFECT OF BIAS CONDITIONS ON AlGaIn/GaN 2DEG HALL PLATES
K.M. Dowling¹, H.S. Alpert¹, P. Zhang², A.N. Ramirez¹,
A.S. Yalamarthy¹, H. Köck³, U. Ausserlechner³, and D.G. Senesky¹
¹Stanford University, USA, ²Tsinghua University, CHINA, and
³Infineon Technologies AG, AUSTRIA

MP-26 TRENCH-ISOLATED BULK-TYPE PRESSURE SENSOR ON SILICON-ON-INSULATOR FOR HIGH-TEMPERATURE AND HIGH-PRESSURE DOWNHOLE APPLICATIONS
E. Chan¹, D. Lin^{1,2,3}, L. Lu^{1,4}, K. Chau^{1,2}, and M. Wong¹
¹Hong Kong University of Science and Technology, HONG KONG,
²Chinese Academy of Sciences, CHINA,
³University of Chinese Academy of Sciences, CHINA, and
⁴Hong Kong University of Science and Technology

Power Generation and Management

MP-27 A YARN-BASED BACTERIA-POWERED BATTERY FOR SMART TEXTILES
Y. Gao, L. Liu, and S. Choi
State University of New York, Binghamton, USA

Resonant Devices

- MP-28** **A NANOMECHANICAL IDENTIFICATION TAG TECHNOLOGY FOR TRACEABILITY AND AUTHENTICATION APPLICATIONS**
M. Ramezani, A.R. Newsome, M. Ghatge, F. Zhang, S. Bhunia, and R. Tabrizian
University of Florida, USA
- MP-29** **CIRCULARLY POLARIZED MECHANICAL RESONANCES**
P.-L. Yu and S.A. Bhave
Purdue University, USA
- MP-30** **ENHANCING MICRO-OVEN POWER AND STIFFNESS IN ENCAPSULATED DEVICES FOR TIMING REFERENCE APPLICATIONS**
L. Comenencia Ortiz¹, D.D. Gerrard¹, I.B. Flader¹, G.D. Vukasin¹, D.B. Heinz¹, J. Rodriguez¹, S. Koppaka¹, D.D. Shin¹, H.-K. Kwon¹, S. Chandorkar², and T.W. Kenny¹
¹Stanford University, USA and ²IISc Bangalore, INDIA
- MP-31** **HIGH $K_t^2 \cdot Q$ LAMB-WAVE SCALN-ON-SILICON UHF AND SHF RESONATORS**
M. Ghatge¹, V. Felmetzger², and R. Tabrizian¹
¹University of Florida, USA and ²OEM Group LLC., USA

Late News

- MP-32** **3D PRINTED MICROFLUIDIC SELECTABLE RATIO MIXER PUMP IN 2 MM³**
G.P. Nordin, H. Gong, and A.T. Woolley
Brigham Young University, USA
- MP-33** **A FULLY-INTEGRATED WEARABLE MICROFLUIDIC ACTUATION AND SENSING PLATFORM FOR BIOMARKER ANALYSIS**
H. Lin¹, S. Lin¹, Y. Zhao¹, H. Hojajji¹, S. Pilehvar¹, S. Thakur², M. Karapetian¹, K. King¹, R. Frias¹, and S. Emaminejad¹
¹University of California, Los Angeles, USA and ²University of California, Berkeley, USA
- MP-34** **A HIGHLY SENSITIVE IMPEDIMETRIC APTASENSOR FOR WEARABLE DETECTION OF HORMONES**
S. Pilehvar, S. Lin, H. Hojajji, Y. Zhao, and S. Emaminejad
University of California, Los Angeles, USA

- MP-35 AN ULTRASONICALLY POWERED ACTIVE STENT FOR ENDOVASCULAR DISEASES**
S. Islam and A. Kim
Temple University, USA
- MP-36 ELECTROCHEMICALLY-FUNCTIONALIZED AND VERTICALLY CONDUCTIVE ADHESIVE TAPES FOR WEARABLE SWEAT BIOMARKER MONITORING**
Y. Zhao, H. Hojajji, and S. Emaminejad
University of California, Los Angeles, USA
- MP-37 HOLLOW FLEXURAL RESONATORS WITH NANOSCALE THICKNESS**
W. Cha, S.M. Nicaise, D.E. Lilley, C. Lin, and I. Bargatin
University of Pennsylvania, USA
- MP-38 IMPLANTABLE, MICROFIBER NEUROELECTRODES FABRICATED OUT OF POLYCRYSTALLINE DIAMOND AND BORON-DOPED DIAMOND**
Y. Guo¹, C.A. Rusinek², R. Rechenberg², B. Fan¹, M.F. Becker², and W. Li¹
¹Michigan State University, USA, and ²Fraunhofer USA, USA
- MP-39 TEMPERATURE-DEPENDENT TRANSIENT BEHAVIOR OF AlGaIn/GaN HIGH ELECTRON MOBILITY PRESSURE SENSORS**
C.A. Chapin¹, K.M. Dowling¹, H.-P. Phan^{1,2}, R. Chen¹, and D.G. Senesky¹
¹Stanford University, USA and ²Griffith University, AUSTRALIA
- MP-40 WHAT IS EFFECTIVE QUALITY FACTOR?**
J.M. Lehto Miller¹, A. Ansari², D.B. Heinz¹, Y. Chen¹, I.B. Flader¹, D.D. Shin¹, L.G. Villanueva³, and T.W. Kenny¹
¹Stanford University, USA, ²Georgia Institute of Technology, USA, and ³École Polytechnique Fédérale de Lausanne, SWITZERLAND

Poster Session 2

Contributed and Late News

Wednesday, June 6

2:10 pm – 4:40 pm

Acoustic Transducers and Delay Lines

WP-01 REALIZING RADIO FREQUENCY ACOUSTIC DELAYS AND TRANSVERSAL FILTERING WITH SUB-2 DB INSERTION LOSS AND 10% FRACTIONAL BANDWIDTH

T. Manzanogue, R. Lu, Y. Yang, and S. Gong
University of Illinois, Urbana-Champaign, USA

WP-02 SURFACE MICROMACHINED PIEZOELECTRIC MICROMACHINED ULTRASONIC TRANSDUCERS WITH HIGH FILL-FACTOR AND HIGH PERFORMANCE

Q. Wang, G. Luo, Y. Kusano, and D.A. Horsley
University of California, Davis, USA

Bio-Inspiration and Biomedical Devices and Systems

WP-03 A TWO-MINUTE ASSAY FOR ELECTRONIC QUANTIFICATION OF ANTIBODIES IN SALIVA ENABLED THROUGH MULTI-FREQUENCY IMPEDANCE CYTOMETRY AND MACHINE LEARNING ANALYSIS

Z. Lin, J. Sui, P. Xie, K. Ahuja, and M. Javanmard
Rutgers University, USA

WP-04 MULTI-MODAL MICROELECTRODE ARRAYS FOR THE INVESTIGATION OF PROTEIN ACTIN'S ELECTRO-MECHANOSENSING MECHANISMS TOWARD NEURODEGENERATIVE DISEASE MODELS ON A CHIP

N. Azim, N. Castaneda, A. Diaz, H. Kang, and S. Rajaraman
University of Central Florida, USA

Characterization, Fabrication and Materials

WP-05 A SIMPLE FABRICATION METHOD FOR DOUBLY REENTRANT OMNIPHOBIC SURFACES VIA STRESS INDUCED BENDING

K.L. Wilke, M. Garcia, D.J. Preston, and E.N. Wang
Massachusetts Institute of Technology, USA

WP-06 ACTIVE SELF-CLEANING SURFACES ON SOLAR MODULES

D. Sun and K.F. Böhringer
University of Washington, USA

- WP-07 DIRECTED SELF ASSEMBLY OF COLLOIDAL PARTICLES FOR HIGH ASPECT RATIO BANDS**
V. Lochab¹, A. Yee², Y. Li³, M. Yoda², A.T. Conlisk¹, and S. Prakash¹
¹Ohio State University, USA, ²Georgia Institute of Technology, USA, and ³Ibaraki University, JAPAN
- WP-08 MECHANICAL CHARACTERIZATION OF ADDITIVELY MANUFACTURED MICROSTRUCTURES USING A PROCESS INTEGRATED MEMS TENSILE TESTER**
I.S. Ladner^{1,2}, J.H. Cho², D.R. Cayll², V.H. Nguyen¹, M.A. Cullinan², and S.K. Saha¹
¹Lawrence Livermore National Laboratory, USA and ²University of Texas, Austin, USA
- WP-09 MULTILAYER ALD CERAMIC FILMS FOR ENHANCEMENT OF PARYLENE BARRIER PROPERTIES IN COMPLIANT NEURAL PROBES WITH BONDED CHIPS**
M. Forssell, X.C. Ong, and G.K. Fedder
Carnegie Mellon University, USA
- WP-10 NANOPRINTING OF MINIATURE COMPOUND REFRACTIVE LENSES FOR DESKTOP HARD X-RAY IMAGING**
M. Mirzaeimoghri^{1,2}, A. Morales¹, C. McCue², D.L. DeVoe², and H. Wen¹
¹National Institute of Health, USA and ²University of Maryland, USA
- WP-11 NANOSTENCIL FABRICATION WITH DOUBLE EXPOSURE OPTICAL LITHOGRAPHY FOR SCALABLE RESIST-FREE PATTERNING OF METAL ON POLYMERS**
J.S. Katz¹, W. Park¹, M.T. Barako², A. Sood¹, M. Asheghi¹, and K.E. Goodson¹
¹Stanford University, USA and ²Northrup Grumman Corporation, USA
- WP-12 NOVEL ROOM TEMPERATURE MICROFLUIDIC DEVICE FABRICATION: A HIGH RESOLUTION, 3D PRINTING APPROACH USING ELECTROHYDRODYNAMIC JET PRINTING**
C. Pannier¹, Z. Wang², D. Hoelzle³, and K. Barton¹
¹University of Michigan, USA, ²University of Notre Dame, USA, and ³Ohio State University, USA
- WP-13 PRECISE MICROSCALE PATTERNING OF BEAD LESS AND UNIFORM NANOFIBER VIA EXTREME NEAR-FIELD ELECTROSPINNING**
D. Shin, J. Kim, and J. Chang
University of Utah, USA

Chemical, Biomedical, and Gas Sensors

- WP-14** **A MICRO COLLECTOR INJECTOR (μ COIN) FOR μ GC SYSTEMS**
M. Akbar, N. Nuño, R. Hower, C. Zhan, J. Potkay, and E. Zellers
University of Michigan, USA
- WP-15** **ENHANCING SELECTIVITY OF CANTILEVER-BASED
RESONANT CHEMICAL SENSORS THROUGH TRANSIENT
MEASUREMENTS AT ELEVATED TEMPERATURES**
P. Getz¹, C. Carron^{1,2}, and O. Brand¹
¹Georgia Institute of Technology, USA and ²Harris Corporation, USA
- WP-16** **MATTRESS-BASED SWEAT MONITORING FOR HUMAN
HEALTH MONITORING AND SMART HOMES**
S. Pavlidis^{1,2}, M.-Y. Tsai², B. Brown², D. Jin²,
J.-D. Velilla³, M. Defranks³, and E. Vogel²
*¹North Carolina State University, USA, ²Georgia Institute of
Technology, USA, and ³Serta Simmons Bedding, USA*
- WP-17** **RAPID DIFFERENTIATION OF HOST AND PARASITE EXOSOME
VESICLES USING PHOTONIC CRYSTAL BIOSENSOR**
Y. Wang, W. Yuan, M. Kimber, M. Lu, and L. Dong
Iowa State University, USA

Micro Robots

- WP-18** **MEMS AIRFOIL WITH INTEGRATED INCHWORM MOTOR
AND FORCE SENSOR**
B. Kilberg, D. Contreras, J. Greenspun, H. Gomez, E. Liu,
and K.S.J. Pister
University of California, Berkeley, USA

Microfluidics

- WP-19** **CMOS COMPATIBLE GHZ ULTRASONIC FRESNEL
MICROFLUIDIC ACTUATOR**
A. Ravi, J. Kuo, and A. Lal
Cornell University, USA

Modeling

- WP-20** **A 5-BIT DIGITALLY OPERATED MEMS ACCELEROMETER**
A. Abbasipour¹, V. Kumar¹, R. Jafari², and S. Pourkamali¹
¹University of Texas, Dallas, USA and ²Texas A&M University, USA

WP-21 ON DECOUPLED QUANTIFICATION OF ENERGY DISSIPATION MECHANISMS IN TOROIDAL RING GYROSCOPES
Y. Wang¹, Y.-W. Lin¹, J. Rodriguez², G.D. Vukasin², D.D. Shin², H.-K. Kwon², D.B. Heinz², Y. Chen², D.D. Gerrard², T.W. Kenny², and A.M. Shkel¹
¹University of California, Irvine, USA and ²Stanford University, USA

Physical and Optical Sensors and Actuators

WP-22 CAPACITIVE TRANSDUCER ENHANCEMENT ON QUADRATURE COMPENSATION ELECTRODE OF YAW RATE GYROSCOPE
P. Shao, E. Canales, and P. Zhu
NXP Semiconductors, USA

WP-23 FACILE FABRICATION OF LOW-COST PASSIVE WIRELESS HUMIDITY SENSOR FOR SMART PACKAGING VIA ALL-LASER PROCESSING OF METALIZED PAPER
R. Rahimi^{1,2}, J. Zhou^{1,2}, H. Jiang^{1,2}, T. Soleimani³, and B. Ziaie^{1,2}
¹Purdue University, USA, ²Birk Nanotechnology Center, USA, and ³Michigan State University, USA

WP-24 NANOSCALE TUNING FORK CAVITY OPTOMECHANICAL TRANSDUCERS WITH DESIGN ENABLED FREQUENCY TUNING AND TEMPERATURE COMPENSATION
R. Zhang¹, R. Ilic², Y. Liu¹, and V. Aksyuk²
¹Worcester Polytechnic Institute, USA, and ²National Institute of Standards and Technology (NIST), USA

WP-25 SMARTPHONE BASED FOCUS-FREE MACROSCOPY USING AN ADAPTIVE DROPLET LENS
H. Huang and Y. Zhao
Ohio State University, USA

WP-26 TWO-CHANNEL WAKEUP SYSTEM EMPLOYING ALUMINUM NITRIDE BASED MEMS RESONANT ACCELEROMETERS FOR NEAR-ZERO POWER APPLICATIONS
R.W. Reger, S. Yen, B. Barney, M. Satches, A.I. Young, T. Pluym, M. Wiwi, M.A. Delaney, and B.A. Griffin
Sandia National Laboratories, USA

Power Generation and Management

WP-27 MICRO BUCKLED BEAM BASED ULTRA-LOW FREQUENCY VIBRATION ENERGY HARVESTER
R. Xu, H. Akay, and S.-G. Kim
Massachusetts Institute of Technology, USA

Resonant Devices

- WP-28** **A SINGLE-CRYSTAL SILICON RESONATOR FOR AM DEMODULATION WITH ADDED SECOND-HARMONIC MODULATION**
M.E. Galanko, Y.-C. Lin, T. Mukherjee, and G.K. Fedder
Carnegie Mellon University, USA
- WP-29** **CROSS-SECTIONAL QUASI-LAMÉ MODES IN THIN-FILM PIEZOELECTRIC-ON-SILICON RESONATORS**
S. Shahraini¹, H. Fatemi², and R. Abdolvand¹
¹University of Central Florida, USA and ²Qorvo, USA
- WP-30** **EIGENMODE OPTIMIZATION AND TOPOLOGICALLY PROTECTED STATES IN MAGNETO-MECHANICAL ULF TRANSMITTER ARRAYS**
I. Grinberg, J. Kim, and G. Bahl
University of Illinois, Urbana-Champaign, USA
- WP-31** **PRECISE LOCAL TEMPERATURE MEASUREMENT OF FULLY ENCAPSULATED OVENIZED MEMS DEVICES**
H.-K. Kwon¹, D.B. Heinz¹, D.D. Shin¹, Y. Chen², L.C. Ortiz¹, G.D. Vukasin¹, and T.W. Kenny¹
¹Stanford University, USA and ²Apple, Inc., USA

Late News

- WP-32** **750 MHZ ZERO-POWER MEMS-BASED WAKE-UP RECEIVER WITH -60 DBM SENSITIVITY**
C. Cassella, M. Assylbekova, W.Z. Zhu, G. Chen, P. Kulik, G. Michetti, N. McGruer, and M. Rinaldi
Northeastern University, USA
- WP-33** **A HIGH-MASS, EIGHT-FOLD SYMMETRIC SILICON CARBIDE MEMS GYROSCOPE**
E. Cook¹, M. Tomaino-Iannucci¹, J. Bernstein¹, M. Weinberg¹, J. Choy¹, K. Hobart², L. Luna², M. Tadjer², R. Myers-Ward², F. Kub², Y. Yang³, E. Ng³, I. Flader, Y. Chen³, and T. Kenny³
¹Draper, USA, ²U.S. Naval Research Laboratory, USA, and ³Stanford University, USA
- WP-34** **A SILICON OPTOMECHANICAL ACCELEROMETER WITH HIGH BANDWIDTH AND SENSITIVITY**
Y. Bao^{1,2}, F. Zhou¹, T.W. LeBrun¹, and J.J. Gorman¹
¹National Institute of Standards and Technology (NIST), USA and ²Theiss Research, USA

- WP-35 DEMONSTRATION OF A MICROFABRICATED SELF-OSCILLATING FLUIDIC HEAT ENGINE (SOFHE)**
T. Monin^{1,2,3}, A. Tessier-Poirier¹, A. Amnache¹, T. Skotnicki³,
S. Monfray³, F. Formosa², and L.G. Fréchet¹
¹Universite de Sherbrooke, FRANCE, ²Université Savoie-Mont-Blanc, FRANCE, and ³STMicroelectronics, FRANCE
- WP-36 DIRECT MEASUREMENTS OF ANCHOR DAMPING IN PRESSURE-LIMITED RING RESONATORS**
G.D. Vukasin¹, J. Rodriguez¹, L. Comenencia Ortiz¹, G.M. Glaze¹,
D.D. Gerrard¹, C.H. Ahn¹, Y. Yang², J. Lake³, R.N. Candler⁴, and
T.W. Kenny¹
¹Stanford University, USA, ²Integrated Device Technology Incorporated, USA, ³uBeam, USA, and
⁴University of California, Los Angeles, USA
- WP-37 IMAGING GIGAHERTZ DYNAMICS IN MICROMECHANICAL RESONATORS USING ULTRAFAST PULSED LASER INTERFEROMETRY**
L. Shao^{1,2}, V.J. Gokhale^{1,2}, J.C. Kuo³, A. Lal³, and J.J. Gorman¹
¹National Institute of Standards and Technology (NIST), USA,
²University of Michigan, USA, and ³Cornell University, USA
- WP-38 KNUDSEN-PUMP-BASED MICRO-HOVERCRAFTS**
J. Cortes, C. Stanczak, and I. Bargatin
University of Pennsylvania, USA
- WP-39 ORIGAMI-ENABLED MICROFLUIDICS**
X. Xie¹, C. Kelly¹, T. Liu¹, R.J. Lang², S. Gandolfo¹, Y. Boukataya³,
and C. Livermore¹
¹Northeastern University, USA, ²Lang Origami, USA, and
³University of Pennsylvania, USA

Poster Session 3

Commercial and Open Poster

Wednesday, June 6

6:30 pm – 8:00 pm

- WCP** **A RISING JOURNAL FROM NATURE PUBLISH GROUP:
MICROSYSTEMS & NANOENGINEERING**
T. Cui¹, T. Liu², and Y. Zhang²
¹*University of Minnesota, USA and*
²*Chinese Academy of Sciences, CHINA*
- WCP** **COMPREHENSIVE MEMS DESIGN ANALYSIS WITH
CoventorMP**
R. Jhaveri and S. Breit
Coventor, Inc., USA
- WCP** **CUSTOMIZED MEMS SOLUTIONS FOR PROOF-OF-PRINCIPLE
THROUGH MEDIUM-VOLUME PRODUCTION**
J. Walker¹, H. Van den Vlekkert², R. Heideman², and A. Leinse²
¹*LioniX International, USA and*
²*LioniX International, THE NETHERLANDS*
- WCP** **DWL 66+: MASKLESS LASER LITHOGRAPHY WITH THE
ULTIMATE LITHOGRAPHY RESEARCH TOOL**
P. Heyl¹, N. Wijnaendts van Resandt², G. Moore¹
¹*Heidelberg Instruments GmbH, GERMANY and*
²*Heidelberg Instruments, Inc., USA*
- WCP** **FULL OPTICAL CHARACTERIZATION OF MEMS: REAL TIME
DYNAMICS AND 3D TOPOGRAPHY**
E. Lawrence¹, D. Oliver¹, M. Heilig², and H. Steger²
¹*Polytec Inc., USA and* ²*Polytec GmbH, GERMANY*
- WCP** **HIGH RELIABLE PZT SPUTTERING TECHNOLOGIES FOR HIGH
PERFORMANCE PIEZOMEMS DEVICES**
H. Kobayashi, T. Tsuyuki, I. Kimura, and K. Suu
ULVAC, Inc., JAPAN
- WCP** **HIGH THROUGHPUT LARGE FEATURE LITHOGRAPHY
WITHOUT THE NEED FOR PHOTOMASKS**
J. Sasserath and J. Drakeford
Advanced Micro Patterning, USA
- WCP** **MOLECULAR VAPOR DEPOSITION (MVD): A VERSATILE,
MULTIFUNCTIONAL TECHNOLOGY FOR IMPROVING
PERFORMANCE AND RELIABILITY OF MEMS BASED
PRODUCTS**
D. Springer, M. Grimes, and K. Atchison
SPTS Technologies, USA

**WCP REVISITING THE SEMINAL BOSCH DEEP REACTIVE ION ETCH
PATENT**

S. Dixon-Warren

TechInsights Inc., CANADA

**WCP THE DHM (DIGITAL HOLOGRAPHY MICROSCOPE) AS
ADVANCED 4D MEMS ANALYZER AND PROFILOMETER**

Y. Emery, J. Parent, and F. Liu

Lyncee Tec SA, SWITZERLAND and Lyncee Tec SA, USA